

Simulation and Preliminary Experimental Study for Self-modulation Experiment at PITZ



G. Pathak¹, M. Gross², M. Khojayan², T. Mehrling¹, A. M. de la Ossa², J. Osterhoff¹, F. Stephan²,
¹Institut für Experimentalphysik, Universität Hamburg, Luruper Chaussee 149, D-22761 Hamburg, Germany
²Deutsches Elektronen-Synchrotron DESY, 22607 Hamburg, Germany

Abstract

A long, relativistic particle beam propagating in an overdense plasma is subject to the self-modulation instability. Simulations were carried out to study the self-modulation of long electron bunches in the plasma. The goal of the study is to optimize the beam and plasma parameters to get maximum beam energy modulation with minimal increase of emittance. Increase in beam energy modulation is observed with increase in plasma density and decrease in beam size. However beam emittance increases rapidly after few millimeter propagation through the plasma because of increase in divergence and compression of beam due to transverse wakefields of plasma. The possible explanation for the emittance growth is presented here.

Beam matching study is also carried out to optimize the beam parameters. The outcome shows that beam matching is unachievable with desired beam and plasma parameters for PITZ self-modulation experiment.

Calibration method of diffraction grating for spectrum analysis is presented in this poster. The calibration achieved is 0.05 nm/pixel or 11.34 nm/mm. This calibrated grating and wavelength distributed white light interference pattern later on will be used in hook's method for gas density measurement.

Self-modulation of electron beam

In its simplest form of self-modulation, a long charge particle beam ($L > \lambda_p$) when propagates through the plasma generates a wake within its body due to perturbation of plasma, which modulates the beam itself, leading to the positive feedback and unstable modulation of the whole beam along the propagation direction. This self-modulation splits the long beam into short bunches of length λ_p , which resonantly drive the plasma wave. The longitudinal electric field is given by

$$E_z = 240 (MV m^{-1}) \left(\frac{n_p}{4 \times 10^{10}} \right) \left(\frac{0.6}{\sigma_z (mm)} \right)^2$$

Where n_p is beam density
 σ_z is longitudinal beam size,

Beam properties

Before plasma

After plasma

Modulation is observed more in the tail of beam.
 Beam is compressed transversely due to transverse wakefield.
 Different compression in x, y direction is due to asymmetrical transverse beam size.

Beam size and plasma density scan for energy modulation

Smaller beam size expels plasma electron more strongly, generating strong transverse wakefields which in turn modulate beam energy strongly (upper figure).
 The beam energy modulation increases with increase in plasma density, is due to the fact that transverse wakefield increases with increase in plasma density again which in turn modulate beam energy strongly (lower figure).

Beam matching for plasma

Beam matching for blowout regime
 $\beta_m \approx \frac{c}{\omega_p}, \gamma_m \approx \frac{c}{\omega_p}, \alpha_m = 0$

Beam matching for linear regime (e.g. Gaussian beam distribution)
 $\beta_m \approx \left(\frac{a}{2m} \right)^{1/4} \sqrt{\frac{a^2 \gamma}{f_0 \sin(k_p r)}}$

Where $\beta_m, \gamma_m, \alpha_m$ are twiss parameters, $\omega_p (= \omega_p / \sqrt{2\gamma})$ is betatron frequency, σ_r is beam transverse size, f_0 is n_b/n_0 , k_p is plasma wave number, γ is the mean beam energy.

For beam matching for blowout regime with plasma density $10^{15} cm^{-3}$ the β_m and corresponding σ_r are quite small. This conclude that beam matching can not be achieved with desired beam and plasma parameters for PITZ self-modulation experiment.

Emittance growth after plasma

Possible explanation:
 General definition of normalized emittance growth
 $\epsilon_{2D}^2 = (\epsilon_x^2)(\epsilon_y^2)(\epsilon_z^2) - (\epsilon_{xy})^2$ (1)
 Considering the correlation between the energy and transverse position is negligible
 $\epsilon_{2D}^2 = (\beta^2 \gamma^2)(\epsilon_x^2)(\epsilon_z^2) - (\beta \gamma)^2 (\epsilon_x \epsilon_z)^2$ (2)
 By the definition of relative energy spread σ_ϵ
 $\sigma_\epsilon = \frac{(\beta^2 \gamma^2 - \beta \gamma)^2}{\gamma^2}$ (3)
 Inserting eq. (3) in equation (2) gives
 $\epsilon_{2D}^2 = (\gamma^2)(\sigma_\epsilon^2 \epsilon_x^2 \epsilon_z^2 + \epsilon_x^2 \epsilon_z^2)$ (4)
 The ratio between 1st and 2nd term of this equation

Before plasma	After plasma
$\frac{\sigma_\epsilon^2 \epsilon_x^2 \epsilon_z^2}{\epsilon_x^2 \epsilon_z^2} \approx 0.8$	$\frac{\sigma_\epsilon^2 \epsilon_x^2 \epsilon_z^2}{\epsilon_x^2 \epsilon_z^2} \approx 18$
For $\sigma_\epsilon = 0.1\%$	For $\sigma_\epsilon = 5\%$
$\epsilon_x = 50 \mu m$	$\epsilon_x = 20 \mu m$
$\epsilon_z = 1.6 mrad$	$\epsilon_z = 10 mrad$
$\epsilon = 0.35 mm mrad$	$\epsilon = 10 mm mrad$
$\gamma = 43$	$\gamma = 43$

This explains that energy spread and beam compression could be major reasons for the emittance growth.

Calibration of diffraction grating using two lasers

The calibration of diffraction grating is done by using two lasers of slightly different colors, a diffraction grating and a screen (camera). The principle is described below.

The diffraction equation is given by
 $d \sin \theta = m \lambda$
 Where d is grooves spacing in the grating,
 θ is the angle of diffraction for a particular λ ,
 m is order of diffraction

$$\theta = \sin^{-1} \left(\frac{d m}{1.666} \right)$$

Where $m = 1$ for first order diffraction, $d = 1.66 \mu m$

If there are two lasers of wavelength λ_1 and λ_2 the angle of diffraction will be different for both, say θ_1 and θ_2 respectively. Let us consider the distance between grating and screen is x then the difference between first order diffraction for both wavelengths is

$$\Delta y = x(\tan \theta_1 - \tan \theta_2)$$

and hence

$$\Delta y = \lambda_1 - \lambda_2$$

The calibration achieved by this method is 0.05 nm/pixel or 11.34 nm/mm

Calibration setup for diffraction grating

First order diffraction for the 670nm and 632.8nm

Diffraction pattern for the 670 nm and 632.8 nm. From right to left 0th, 1st, 2nd ... order diffraction pattern. 0th order diffraction overlaps for both lasers because it is just a reflection from grating.

Wavelength distribution of white light interference

Outlook

- Further optimization by simulations will be done to achieve maximum energy modulation and minimize the emittance growth e.g. with energy chirp beam and density tapered plasma.
- Experiments are ongoing for gas density measurement.
- Different methods will be implied for gas and plasma density measurement.

References

- Proton-driven Plasma-wakefield Acceleration – A. Caldwell et al. Nature Physics 5, 363–367 (2009)
- Self-Modulation Instability of a Long Proton Bunch in Plasmas – N. Kumar et al. PRL 104, 255003 (2010)
- Growth and Phase Velocity of Self-Modulated Beam-Driven Plasma Waves – C. B. Schroeder et al. PRL 107, 145002 (2011)
- HIPACE: a quasi-static particle-in-cell code – T. Mehrling et al. Plasma Phys. Control. Fusion 56 084012 (2014)
- Transverse emittance growth in staged laser-wakefield acceleration – T. Mehrling et al. PRSTAB, 15, 111303

*Email: gaurav.pathak@desy.de